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on 5/1/06

Michael S. Huppert

name of person signing certification

Signature

May 1, 2006

Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 5686

Mitsuo SAITO et al. : Attorney Docket No. 2003_1228A

Serial No. 10/649,670 : Group Art Unit 1763

Filed August 28, 2003 : Examiner Allan W. Olsen

PLASMA PROCESSING METHOD AND APPARATUS

AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action of November 29, 2005, the period for response having been extended for two (2) months by the attached petition, please amend the present application as follows:

Amendments to the Abstract

Kindly replace the original abstract with the attached substitute abstract.